



GAU 28157

35.C13630

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#15

In re Application of:)
MASAAKI IWANE ET AL.) Examiner: J. Diaz
Application No.: 09/346,678) Group Art Unit: 2815
Filed: July 2, 1999)
For: CRYSTAL GROWTH PROCESS,)
SEMICONDUCTOR DEVICE,)
AND ITS PRODUCTION PROCESS) October 24, 2001

11-1-01

T. Flower

Commissioner for Patents
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of those documents are also enclosed, together with a copy of a European Search Report citing them.

Each item of information in this information disclosure statement was first cited in any communication from a foreign Patent Office in a counterpart foreign application not more than three months prior to the filing date of this Statement.

A check in the amount of \$180.00 is submitted herewith; any deficiency in this fee should be charged, and any overpayment should be credited, to Deposit Account 06-1205.

10/29/2001 AADDF01 00000002 09346678

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180.00 DP

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,



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